

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/817,406	LYUKSYUTOV ET AL.	
		Examiner	Art Unit	Page 1 of 1
		Roberts Culbert	1763	

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-			
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
Q					
R					
S					
T					

NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)		
U	Sergei F. Lyuksyutov et al. "Electrostatic Nanolithography in Polymers Using Atomic Force Microscopy" Published online, June 22, 2003		
V			
W			
X			

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.